

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L. L. P.

1300 I STREET, N. W. WASHINGTON, DC 20005-3315

202 • 408 • 4000 FACSIMILE 202 • 408 • 4400



ATLANTA 404 • 653 • 6400 PALO ALTO 650 • 849 • 6600

WRITER'S DIRECT DIAL NUMBER:

TOKYO 011-813-3431-6943 BRUSSELS 011+322+646+0353

(202) 408-4024

April 26, 2001

ATTORNEY DOCKET NO.: 04329.2566

CUSTOMER NUMBER: 22,852

Box Patent Application Assistant Commissioner for Patents Washington, D.C. 20231

New U.S. Patent Application

Title: FILM FORMATION METHOD, SEMICONDUCTOR ELEMENT AND METHOD THEREOF, AND METHOD OF MANUFACTURING A DISK-SHAPED STORAGE MEDIUM

Inventors: Shinichi ITO and Katsuya OKUMURA

Sir:

We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

- Application 61 pages, including 1 independent claim and 23 claims 1. total.
- Drawings 11 sheets of formal drawings containing 28 figures. 2.
- 3. Declaration and Power of Attorney.
- Recordation Form Cover Sheet and Assignment to Kabushiki Kaisha 4. Toshiba.
- Certified copy of Japanese Application No. 2000-127953, filed April 27, 5. 2000.
- Certified copy of Japanese Application No. 2000-311124, filed October 6. 11, 2000.



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- 7. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with 7 documents attached.
- 8. The filing fee is calculated as follows:

					\$710	\$	710.00
Basic Application Filing Fee	Number of Claims		Basic	Extra Claims			
Total Claims	23	-	20	3	x \$18		54.00
Independent Claims	1	-	3		x \$80		
[] Presentation of Multiple Dep. Claim(s) +\$270							
Subtotal						\$	764.00
Reduction by 1/2 if small entity						-	
TOTAL APPLICATION FILING FEE						\$	764.00

9. A check for \$804.00 is enclosed. The fee includes:

\$710.00 filing fee; \$54.00 additional claims fee; and \$40.00 Assignment recordation fee.

Applicants claim the right to priority based on Japanese Application No. 2000-127953, filed April 27, 2000 and Japanese Application No. 2000-311124, filed October 11, 2000.

Please address all correspondence with respect to this application to:

Finnegan, Henderson, Farabow, Garrett & Dunner, L.L.P. 1300 I Street, N.W. Washington, D.C. 20005-3315

Please accord this application a serial number and filing date and record and return the Assignment to the undersigned.

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The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

By:

Richard V. Burgujian

Reg. No. 31,744

RVB/FPD/peg Enclosures